



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7745**

Shoriki NARITA et al. : Docket No. 2003-1226

Serial No. 10/651,103 : Group Art Unit 2825

Filed August 29, 2003 : Examiner Igwe U. Anya

BUMP FORMING APPARATUS FOR : **Mail Stop: AMENDMENT**
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVAL METHOD
FOR CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVING UNIT FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, AND CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of July 27, 2004, a Petition for a one-month extension of time being filed concurrently herewith, please amend the above-identified application as follows.